



Docket No. 0008-FA-
J617 27 APR 2001 PCT/PTO

PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re Application of Hunt et al.

Group Art No. 1762 (U.S. parent)

U.S. Application No. 09/748,714 (U.S. National filing)
 PCT Application No. PCT/US00/15416 (PCT filing)

Filed: 21 December 2000

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35416

For: CHEMICAL VAPOR DEPOSITION METHODS FOR MAKING
POWDERS AND COATINGS, AND COATINGS MADE
USING THESE METHODS

Request to Consolidate Searching

Assistant Secretary and Commissioner of Patents and Trademarks
Washington D.C. 20231

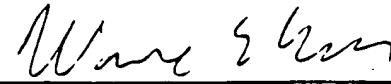
The Above-Identified application was filed both as a U.S. national application and
a PCT application on 21 December 2000. The applications are identical.

A copy of this Request is being sent to for entry on both the U.S. national file and the
PCT file.

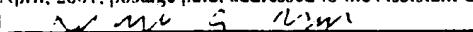
The U.S. Patent Office has been designated as the International Searching Authority.

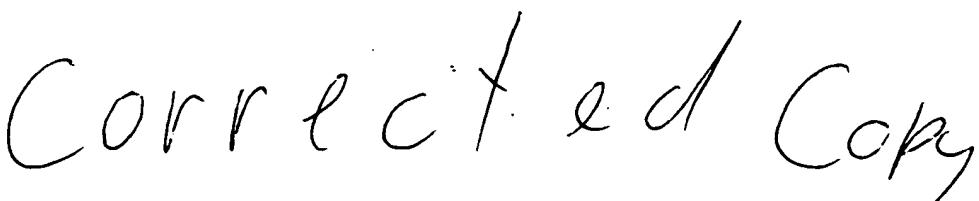
To avoid duplication of effort and costs, it is requested that the national and
international searches be coordinated and to be done by the same examiner.

5 April, 2001


Wayne E. Nacker, Reg. 29,571

CUSTOMER NO. 24948

I, Wayne E. Nacker, hereby certify that this document and the documents listed above were deposited with the U.S. Postal Service
on 5 April, 2001, postage paid, addressed to the Assistant Commissioner for Patents, Washington D.C.
20231 


Corrected Copy